

PATENT

Agent's Docket No. 10963-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of

RABAH BOUKHERROUB et al

Serial No: **09/803,044**

Art Unit: **1765**

Filed: **12-March-2001**

For: **PASSIVATION OF POROUS SEMICONDUCTORS**

October 05, 2001

Commissioner of Patent and Trademarks

Washington, D.C. 20231

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Commissioner of Patent and Trademarks

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TRANSMITTAL LETTER **TC 1700**

Please find enclosed for filing:

- **PRELIMINARY AMENDMENT** dated October 05, 2001

Respectfully submitted

BY: 

Richard J. Mitchell

Reg. No. 34,519

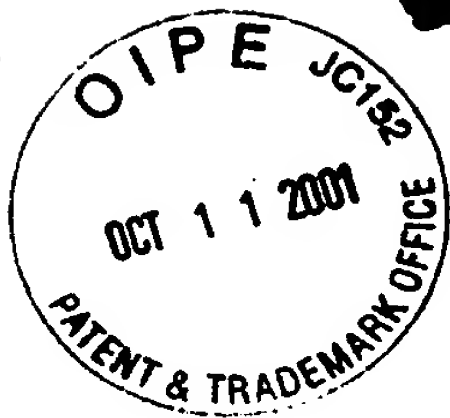
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TECHNICAL
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PRELIMINARY AMENDMENT

Sir:

Please amend the above-referenced application as follows:

IN THE CLAIMS:

Please add new claims 32 to 35 as follows:

-- 32. An electronic/photonic/optoelectronic device comprising a porous silicon structure made by the process defined in claim 1. --

-- 33. An electronic/photonic/optoelectronic device comprising a porous silicon structure made by the process defined in claim 20. --

-- 34. A device comprising a porous silicon structure made by the process defined in claim 1 for the detection of DNA or proteins for genomics and proteomics applications. --

-- 35. A device comprising a porous silicon structure made by the process defined in claim 20 for the detection of DNA or proteins for genomics and proteomics applications. --

no evidence
to detect
for use in
not to mislead